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PATENT

Attorney Docket No.: NICHIA-00700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#5/IDS

T. Feaster

7/19/00

In re Application of:

) Group Art Unit:

)

Shuji Nakamura *et al.*

) Examiner:

)

Serial No.:

) INFORMATION DISCLOSURE

Filed: January 25, 2000

) STATEMENT

)

For: **NITRIDE SEMICONDUCTOR  
DEVICE**

) 260 Sheridan Avenue, Suite 420

) Palo Alto, California 94306

) (650)833-0160

Assistant Commissioner for Patents  
Washington, D.C. 20231

JK. 892 found  
BWB

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

Applicants have become aware of the following printed publication which may be material to the examination of this application:

- Japanese publication number 9-116130.

This Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

NOT CONSIDERED FOR MAT  
NO TRANSLATION  
BWB BAUERSTOCK  
9/15/00

Respectfully submitted,

HAVERSTOCK & OWENS LLP

Dated: January 25, 2000

By: Thomas B. Haverstock

Thomas B. Haverstock

Reg. No.: 32,571

Attorneys for Applicants